

Docket No.: 21806-00157-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Robert T. Froebel et al.

Application No.: 10/707,864

Confirmation No.: 1863

Filed: January 19, 2004

Art Unit: 2877

For: ALIGNMENT MARK SYSTEM AND
METHOD TO IMPROVE WAFER
ALIGNMENT SEARCH RANGE

Examiner: I. O. Akanbi

AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

This is in response to the Final Rejection mailed February 8, 2007 in the above-captioned case.

Amendments to the Claims are reflected in the Listing of Claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.